## **PATENT APPLICATION**

Attorney Docket No. 8071-103 (OPP052118US)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**APPLICANT:** 

Hyun-Jae KIM et al.

INTERNATIONAL APPLN NO.:

PCT/KR2004/000520

INTERNATIONAL FILING DATE:

12 March 2004

**SERIAL NO:** 

Unassigned

FILED:

Concurrently Herewith

FOR:

CRYSTALLIZATION APPARATUS AND METHOD OF AMOPHOUS

**SILICON** 

Commissioner for Patents Box 1450 Alexandria, VA 22313-1450

## PRELIMINARY AMENDMENT

Sir:

Prior to examination on the merits, please amend the above identified application as set forth hereinbelow:

## **CERTIFICATION UNDER 37 C.F.R. ' 1.10**

hereby certify that this New Application Transmittal and the documents referred to as enclosed therein are being deposited with the United States Postal Service on this date <a href="September 13, 2005">September 13, 2005</a> in an envelope as "Express Mail Post Office to Addressee" Mail Label Number <a href="EV702320046US">EV702320046US</a> addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Frank Chau
(Type or print name of person mailing paper)

(Signature of person mailing paper)